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eProcurement
System**

eProcurement System Government of India**Published Corrigendum Details**

Date : 02-Apr-2025 02:27 PM

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Organisation Chain :	Indian Institute of Technology Ropar
Tender ID :	2025_IITRP_852197_1
Tender Ref No :	2016-24
Tender Title :	Tender for Supply and Installation of Vacuum Chamber for the Pulsed Laser Deposition System
Corrigendum Type :	Retender

Corrigendum Document Details

Corr.No.	Corrigendum Title	Corrigendum Description	Corrigendum Reason	Published Date	Document Name	Doc Size(in KB)
1	RETENDER CORRIGENDUM	RETENDER CORRIGENDUM	Minimum Bids Not Received	02-Apr-2025 02:24 PM	CORRRETENDER2016.pdf	356.13



भारतीय प्रौद्योगिकी संस्थान रोपड़
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संख्या. 2016-24/PH-10021/INSTT/PS/

02.04.2025

शुद्धिपत्र

CORRIGENDUM

संदर्भ निविदा सूचना संख्या 2016-24/PH-10021/INSTT/PS/ और CPPP निविदा आईडी संख्या 2025_IITRP_852197_1 **Tender for Supply & Installation of Vacuum Chamber for the Pulsed Laser Deposition System** हेतु निविदा। निविदा निम्नानुसार पुनः निविदा की गई है:

Reference Tender Notice No. 2016-24/PH-10021/INSTT/PS/ and CPPP tender id number 2025_IITRP_852197_1 for **Tender for Supply & Installation of Vacuum Chamber for the Pulsed Laser Deposition System**. The tender has been re-tendered as follows:

बोली अपलोड करने की अंतिम तिथि और समय Last Date and Time for Uploading of Bids	16.04.2025 (15:00 Hrs)
तकनीकी बोली खोलने की तिथि और समय Date and Time of Opening of Technical Bids	16.04.2025 (15:30 Hrs)

अन्य विवरण और नियम और शर्तें भी अपरिवर्तित रहेंगी।

The other details and terms & conditions also remain unchanged.

(Registrar)